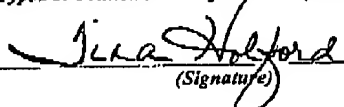


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. EN9-98-122US3
Applicant(s): <i>Farguhar, et al.</i>			
Application No. 09/781,730	Filing Date 02-12-2001	Examiner Goff II, John L.	Group Art Unit 1733
Invention: SEMICONDUCTOR DEVICE HAVING A THERMOSET-CONTAINING DIELECTRIC MATERIAL AND METHODS FOR FABRICATING THE SAME			
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I hereby certify that this <u>Response to Interview Summary (1 page)</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>(571) 273-8300</u>) on <u>August 16, 2005</u> (Date)			
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Applicant(s): Farquhar *et al.*

Examiner: Goff II, John L.

Serial No.: 09/781,730

Art Unit: 1733

Filed: 02/12/2001

Title: SEMICONDUCTOR DEVICE HAVING A THERMOSET-CONTAINING
DIELECTRIC MATERIAL AND METHODS FOR FABRICATING THE SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Response to Interview Summary

Sir:

In response to the Examiner's Interview Summary mailed July 25, 2005, for the interview held July 12, 2005, Applicants acknowledge that said Interview Summary accurately reflects the substance of the interview.

Date: 08/16/2005

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